

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>
	10/519,266	FEKETE ET AL.
	<b>Examiner</b> Christopher S. Kim	<b>Art Unit</b> 3752

**SEARCHED**

<b>INTERFERENCE SEARCHED</b>			
<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>